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Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet	1	of	2
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Complete if Known

Application Number	09/705,447
Filing Date	11/13/2000
First Named Inventor	Miron
Group Art Unit	2877
Examiner Name	Lyons
Attorney Docket Number	2965/MIRON/US

U.S. PATENT DOCUMENTS

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Examiner
Signature

Date _____

Considered

Jan. 29, 2003

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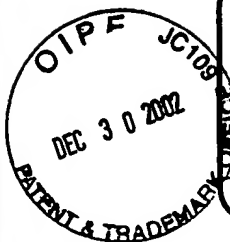
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Substitute for form 1449B/PTO		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>		Application Number	09/705,447
		Filing Date	11/13/2000
		First Named Inventor	Nicolae Miron
		Group Art Unit	2877
		Examiner Name	Lyons
		Attorney Docket Number	2965/MIRON/US
Sheet 2	of 2		

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
MAL		M. Born, E. Wolf, "Principles of Optics," Chapter 7.6, pp. 359-409, 7-th Edition, Cambridge University Press, Cambridge, 1999	
MAL		A.G. Fox and T. Li, in "Resonant Modes in a Maser Interferometer," "The Bell System Technical Journal", pp. 453-488, March 1961	
MAL		G.D. Boyd and K. Kogelnik, in "Generalized Confocal Resonator Theory", "The Bell System Technical Journal", pp. 1347-1369, July 1962	
MAL		N. Chitica et al., "Monolithic InP-based Tunable Filter with 10-nm bandwidth for Optical data Interconnects in the 1550-nm Band," IEEE Photonics Technology Letters, vol. 11, No. 5, pp. 584-586, May 1999	
MAL		A. Spisser et al., "Highly Selective and Widely Tunable 1.55-µm InP/Air-Gap Micromachined Fabry-Perot Filter for Optical Communications," IEEE Photonics Technology Letters", vol. 10, pp. 1259-1261, Sept. 1998	
MAL		P. Tayebati, et al., "Microelectromechanical Tunable Filter With Stable Half Symmetric Cavity," Electronics Letters, vol. 34 (1998), No. 20, pp. 1967-1968	
MAL		D. Vakhshoori, et al., "2mW CW Singlemode Operation of a Tunable 1550nm Vertical Cavity Surface Emitting Laser With 50nm Tuning Range," "Electronics Letters", vol. 35 (1999), No. 11, pp. 900-901	
MAL		K. Hirabayashi et al. "Tunable Liquid-Crystal Fabry-Perot Interference Filter for Wavelength-Division Multiplexing Communication Systems," "Journal of Lightwave Technology", vol. 11, No. 12, pp. 2033-2043, Dec. 1993	

Examiner Signature	Date Considered Jan. 29, 2003
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